OCT 2 8 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

-Am lication_Serial_No	10/082,599
And lication Serial No.	5736
Filing Date	February 22, 2002
Inventor	
Assignee	Micron Technology, Inc.
Group Art Unit	1763
Examiner	Karla A. Moore
Attorney's Docket No	
Customer No	
Title: Interfacial Structure for Semicondo	uctor Substrate Processing
Chambers and Substrate Transfer Cha	mbers and for Semiconductor
Substrate Processing Chambers and	Accessory Attachments, and
Semiconductor Substrate Processor	•

RESPONSE TO AUGUST 14, 2003 OFFICE ACTION



To:

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

VIA U.S. EXPRESS MAIL

From:

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Responsive to the Office Action dated August 14, 2003, Applicant amends and remarks as follows:

<u>AMENDMENTS</u>